

Electronic Patent Application Fee Transmittal

Application Number:	10606512			
Filing Date:	26-Jun-2003			
Title of Invention:	METHOD FOR CLEANING A PROCESSING CHAMBER AND METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE			
First Named Inventor/Applicant Name:	Jung-Wook Kim			
Filer:	Frank Chau			
Attorney Docket Number:	8054-23 (AW8037US/JJ)			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Utility Appl issue fee	1501	1	1440	1440
Publ. Fee- early, voluntary, or normal	1504	1	300	300
Statutory disclaimer	1814	1	130	130
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1870